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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
David Wei Wang

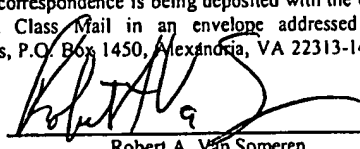
Serial No.: 10/626,916

Filed: July 25, 2003

For: Mesh Screen Apparatus and Method of
Manufacture

§
§ Group Art Unit: 3672
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§ Examiner: House, Letoria G.
§
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§ Atty. Docket: 68.0345
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§

Commissioner
for Patents
PO Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
May 5, 2006	
Date	Robert A. Van Someren

REPLY

Dear Sir:

In response to the Office Action mailed March 16, 2006, Applicants submit the following: